

EV318285108

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No. 09/905,320
Confirmation No. 6172
Filing Date July 13, 2001
Inventor Cem Basceri et al.
Assignee Micron Technology, Inc.
Group Art Unit 1762
Examiner Eric B. Fuller
Attorney Docket No. MI22-1657
Customer No. 021567
Title: Chemical Vapor Deposition Methods of Forming Barium Strontium Titanate
Comprising Dielectric Layers, Including Such Layers Having a Varied
Concentration of Barium and Strontium Within the Layer


SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References -- See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with
37 CFR §1.56. Copies of the cited art are included. No admission is made
regarding whether all the submitted references are prior art.

Respectfully submitted,

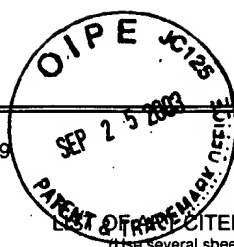
Dated: 9-25-03

By: 
Mark S. Matkin
Reg. No. 32,268

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Sheet 1 of 1

Form PTO-1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE CITED BY APPLICANT (Use several sheets if necessary)	ATTY. DOCKET NO. MI22-1657	SERIAL NO. 09/905,320
	APPLICANT: Cem Basceri et al.	
	FILING DATE July 13, 2001	GROUP 1762

U.S. PATENT DOCUMENTS

*Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	6,372,686 B1	04/16/02	Golden			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AJ							
	AK							
	AL							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

	AM		
	AN		
	AO		
EXAMINER		DATE CONSIDERED	

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.